



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	Application of:	)
Satos	hi TAKANA et al.	) )
Applic	eation No.: 10/808,299	) Group Art Unit: 1756 )
Filed:	March 24, 2004	) Examiner: TBA )
For:	SET OF MASKS, METHOD OF GENERATING MASK DATA AND METHOD FOR FORMING A PATTERN	) ) ) )

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§1.56 and 1.97(b), applicants bring to the Examiner's attention the documents listed on attached Form PTO-1449. Copies of the listed documents are attached. Applicants respectfully request that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed with the above-referenced application.

Following are concise statements of relevance of the non-English language documents. English language abstracts are attached.

Customer No. 22,852 Attorney Docket No. 03180.0360

1. Japanese Patent Laid-Open (Kokai) No. 09-232233 - This document

discloses a lithography method including resist pattern slimming.

2. Japanese Patent Laid-Open (Kokai) No. 2002-009056 - This document

discloses a patterning method including a hard-mask slimming process.

This submission does not represent that a search has been made or that no

better art exists and does not constitute an admission that each or all of the listed

documents are material or constitute "prior art." If the Examiner applies any of the

documents as prior art against any claim in the application and applicants determine

that the cited documents do not constitute "prior art" under United States law, applicants

reserve the right to present to the Office the relevant facts and law regarding the

appropriate status of such documents. Applicants further reserve the right to take

appropriate action to establish the patentability of the disclosed invention over the listed

documents, should one or more of the documents be applied against the claims of the

present application.

If there is any fee due in connection with the filing of this Statement, please

charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,

GARRETT & DUNNER, L.L.P.

Dated: August 4, 2004

Richard V. Burgujian

Reg. No. 31,744

Enclosures RVB/FPD/cma

ERNEST F. CHAPMAN Reg. No. 25,961

## INFORMATION DISCLOSURE CITATION

	03180.0360 05141 8 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1	Application No.	10/808,299	
Applicants	Satoshi Tanaka et al.			
Filing Date	March 25, 2004	Group:	TBA	

	U.S. PATENT DOCUMENTS					
Examiner Initial*	Document Number	Issue Date (Publ. Date)	Name	Class	Sub Class	Filing Date If Appropriate
	5,364,716	11/15/1994	Nakagawa et al.	430	5	
	2002-0160590 A1	(10/31/2002)	Hashimoto et al.	438	528	

FOREIGN PATENT DOCUMENTS						
	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
	JP 09-232233	09/05/1997	Japan			Abstract
	JP 2002-009056	01/11/2002	Japan			Abstract
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)				

Examiner		Date Considered	
	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		
Form PTO 1449	Patent and	Trademark Office - U.S. Department of Commerce	